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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor application of:

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Bo Gu, et al.

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ULTRA FAST LASERS

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**STATUS INQUIRY**

Commissioner for Patents  
U.S. Patent & Trademark Office  
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Sir:

Please inform us of the status of the above-identified patent application and as to when we may expect an Office Action from the U.S. Patent and Trademark Office.

Respectfully submitted,

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